## JT12 Rec'd PCT/PTO 2 7 JAN 2005 MODIFIED PTO/SB/08 A & B (06-03)

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					Application Number	Not yet assigned	
	<u>INFO</u>	RMATION	DISCLO	SURE	Confirmation Number	Not-yet assigned	
1	STAT	EMENT BY	APPLIC	CANT	Filing Date	January 27, 2005	
					First Named Inventor	Vito LAMBERTINI	
	(us	First Named Inventor Vito LAMBERTINI Art Unit Not yet assigned 2879					
					Examiner Name	Not yet assigned LAABE X	
	Sheet	1	of	1	Attorney Docket Number	O85361	

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Examiner Initials*		Number	Kind Code <sup>2</sup> (if known)		Name of Patentee or Applicant of Cited Document		
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Examiner	Cite No.1	Foreign Patent Document			Publication Date	Name of Patentee or	
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OL		JP	2000 267 585	Α	09/29/2000	Toshiba Corp.	
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Examiner Initials*	Cite No.i	NON PATENT LITERATURE DOCUMENTS  Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation
1		Hideki Masuda et al.: "Preparation of Microourous Metal Membranes by Two-Step Replication of the microstructure of Anodic Alumina" Thin Solid Films, Elsevier-Sequoia S.A. Lausanne, CH, Vol., 223, no. 1, January 15, 1993, pages 1-3 XP000367988	

**Examiner Signature** Date Considered

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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